

Requesting Access to the Service of the Nanostructuring Lab of the Max-Planck-Institute for Solid State Research

Information on Applicant:

Last Name:

First Name:

Status: Student Assistant Bachelor Stud. Master Stud. PhD Student
Postdoc Senior Scientist Scientific Technician

Institution: Max-Planck-Institute for Solid State Research

Department /Research Group:

Day-to-Day Supervisor:

MPI-FKF Email Address:

Phone No.:

Language speaking: German English

Research Topic:

Information on the Needs

Short Description of Processing Project / Purpose/ Estimate about Extent and Duration :

Needs:	Optical Lithography	Service	Direct Access
	Focused Ion Beam Processing	Service	
	EDX Analysis	Service	
	Electron Beam Lithography	Service	Direct Access
	Scanning Electron Microscope Imaging	Service	Direct Access
	Wire Bonding	Service	
	Lift-off / Wet Etching	Service	Direct Access

Vacuum Deposition	Service	Direct Access
Reactive Ion Etching	Service	
Atomic Layer Deposition	Service	
(Al,Ga)As MBE Growth	Service	
HF Wet Etching	Service	
Others:		

Sample Materials:

Date:

Signature of Applicant:

To be filled/confirmed by the Department Director / Research Group Mentor:

Name of Director:

Applicant is

Max-Planck employee / Max Planck fellowship holder / PhD student with MPS contract
Guest at institute due to external collaboration / Master student / Bachelor student

External Institution:

Student Assistant (HIWI)

Duration: The direct access to the NSL facilities is generally limited to one year. On request, further extensions are possible.

Direct access should be limited to (< one year) .

Remark:

Date:

Signature of MPI-FKF Director: